

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Kouichi MEGURO, et al.

Serial Number: Not Yet Assigned

Filed: November 24, 2003

**Customer No.: 38834**

For: SUBSTRATE SHEET MATERIAL FOR A SEMICONDUCTOR DEVICE AND A  
MANUFACTURING METHOD THEREOF, A MOLDING METHOD USING A  
SUBSTRATE SHEET MATERIAL, A MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

November 24, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and  
Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please  
charge Deposit Account No. 50-2866.

Respectfully submitted,  
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Enclosures: PTO-1449; References(3)

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Atty. Docket No. 032121	Serial No. New Appln.
	Applicant(s): Kouichi MEGURO, et al.	
	Filing Date: November 24, 2003	Group Art Unit:

### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

### FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AE 10-79362	03/24/98	Japan	Abstract
_____ AF 2000-12745	01/14/00	Japan	Abstract & Discussed in the Spec.
_____ AG 2002-110718	04/12/02	Japan	Abstract & Discussed in the Spec.
_____ AH			
_____ AI			

### OTHER DOCUMENTS

_____	AJ	
_____	AK	
Examiner		Date Considered